ormation of Meta	I Gate for Dual Gat	e Oxide Application							
ents				nvention: Selective Formation of Metal Gate for Dual Gate Oxide Application					
1450 Amendment and	Response to Office	Action in the above-i	dentified applic	ation.					
lated and is transi	mitted as shown belo	ow							
	CLAIMS AS	AMENDED							
AIMS REMAINING TER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE		ADDITIONAL FEE				
22 -	20 =	2	X \$1	8.00	\$36				
2 -	3 =	0	X \$8	86.00	\$0				
ims (check if appl	icable)		\$29	00.00	\$0				
ST MONTH	2 ND MONTH ⊠ 420.00	3 RD MONTH	4 TH MONTH 1,480.00	- 1	\$420				
Other Fees:					\$0				
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Daniel R. McClure, Reg. No. 38,962

Aug 23, 20 0 4
Date



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Sheng Hsiung Chen

Confirmation Number: 3764

Serial No.: 09/905,408

Group Art Unit: 2818

Examiner: Berry, Renee

Filed: 07/16/2001

TKHR Docket No. 252016-1130

Top-Team Ref. 0503-A30726US

For:

SELECTIVE FORMATION OF METAL GATE FOR DUAL GATE OXIDE

APPLICATION

Certificate of Mailing

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to: Mail Stop Amendment; Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on August 23, 2004.

Signature – Hui Chin Barnhill

AMENDMENT AND RESPONSE TO OFFICE ACTION

Mail Stop –Amendment **Assistant Commissioner for Patents** P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The Office Action mailed March 29, 2004 has been carefully considered. In response thereto, please enter the following amendments and consider the following remarks.

08/26/2004 WASFAW1 00000014 09905408

01 FC:1202

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